

- Triode Sputter Ion Pumps operate in the pressure range 10⁻³ to 10⁻¹⁰ Torr. These pumps are used to create UHV in charged particle accelerators, surface analytical spectrometers, mass spectrometers etc. Technology for 35, 70, 140 & 270 LPS capacity has been developed.
- Technology has been transferred to pvt industry.